

# Simulation of a Tsang Suspension

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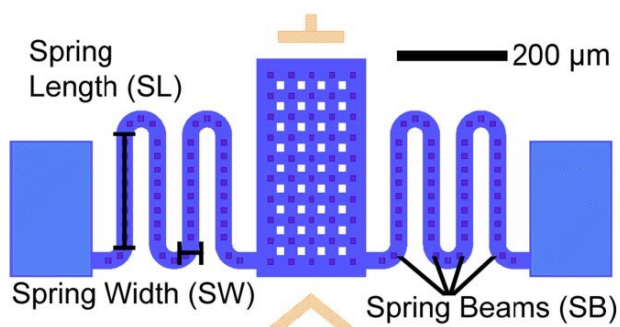
## Abstract

This paper investigates the effects of design parameter variation on the mechanical performance of the out-of-plane assembly mechanism of the Tsang suspension. A variety of designs exploring the design space were fabricated using SU-8 as a structural material. We used the Structural Mechanics Module in the COMSOL Multiphysics® software to simulate the reaction forces of the design. COMSOL Multiphysics® will help us to choose the optimal design parameters of Tsang structures. Figure 1 shows a two dimensional layout of a generic Tsang suspension, which consist of two anchors connected by two identical springs joined by a plate which could potentially hold a transducer for MEMS applications. Figure 2 shows a simulated image of an assembled Tsang suspension. Figure 3 shows an SEM image of an SU-8 fabricated Tsang Suspension.

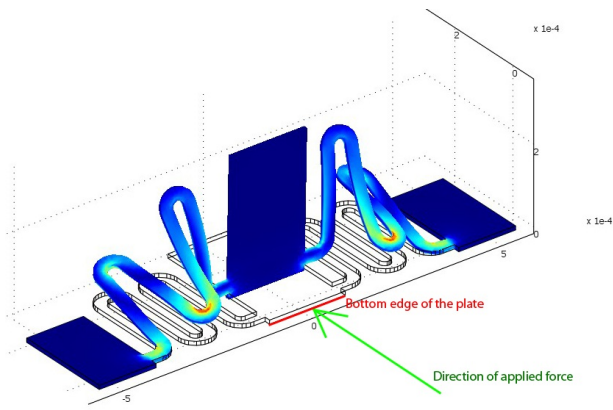
## Reference

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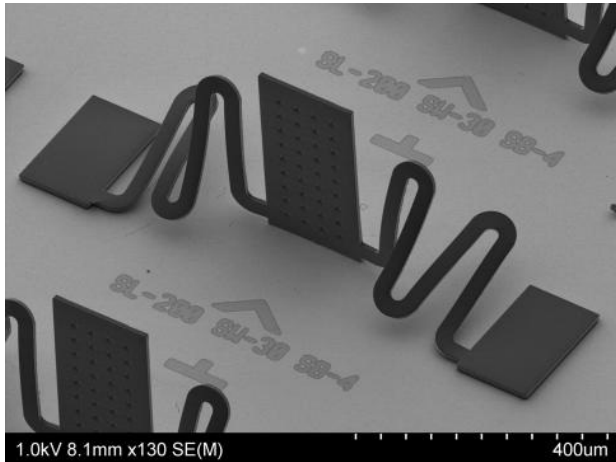
## Figures used in the abstract



**Figure 1:** Layout of a Tsang suspension



**Figure 2:** Simulation of a Tsang suspension showing the direction of the applied boundary condition



**Figure 3:** SEM image of an assembled Tsang suspension